

Notice of References Cited	Application/Control No. 10/749,647	Applicant(s)/Patent Under Reexamination PARK, CHEOLSOO	
	Examiner Christy L. Novacek	Art Unit 2822	Page 1 of 1

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	U	Wolf, S. and Tauber, R.N., "Silicon Processing for the VLSI Era", Vol. 1, pp. 539-541, 1986
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.